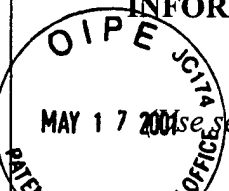


INFORMATION DISCLOSURE STATEMENT 	ATTY. DOCKET NO. 10251	SERIAL NO. 09/778,558
	APPLICANT Lu, et al.	
	FILING DATE February 7, 2001	GROUP 1775

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
Kn	4861644	8/29/89	Young, et al.	428	195	
	5605750	2/25/97	Romano, et al.	428	304.4	
	4377616	3/22/83	Ashcraft, et al.	428	213	
	4632869	12/30/86	Park, et al.	428	315.5	
	5885721	3/23/99	Su, et al.	428	516	
	6118218	9/12/00	Yializis, et al.	315	111.21	
	5981079	11/9/99	Mount, III, et al.	428	461	
	5244861	9/14/93	Campbell, et al.	503	227	
	6020398	2/1/00	Erdtmann, et al.	523	160	
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Kn	09/079807		Pip			

FOREIGN PATENT DOCUMENTS

DOCUMENT NUMBER	PUBL. DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION
					YES NO

OTHER DISCLOSURES (Including Author, Title, Date, Pertinent Pages of Publication, Etc.)

Kn	AO	S.A.Pirzada, A. Yializis, W. Decker, R.E. Ellwanger; "Plasma Treatment of Polymer Films"; Society of Vacuum Coaters 42nd Annual Technical Conference Proceedings, Chicago, 1999, pp. 301-306.
	AP	

EXAMINER



DATE CONSIDERED

5/16/02

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